



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#9

PPLICANT:

Bradley Dale Mitchell

RECEIVED

SERIAL NO.:

09/943,569

APR 2 2 2004

FILING DATE:

August 30, 2001

OFFICE OF PETITIONS

TITLE:

SYSTEM AND METHOD FOR REMOVING DEPOSITED MATERIAL

FROM WITHIN A SEMICONDUCTOR FABRICATION DEVICE

EXAMINER:

Markoff, Alexander

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ART UNIT:

1746.

CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop: Petition, Commissioner for Patents, P.O. Box 1450, Alexandria VA 22313-1450, on the date printed below:

Date: 4115/04

Name:

Beatrice Orozco

MAIL STOP PETITION COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

This paper is responsive to the Office Action dated **December 4, 2002**. Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 27 of this paper.

Amendments to the Drawings begin on page 31 of this paper.

Amendments Remarks / Arguments begin on page 32 of this paper.